

Search Notes



Application/Control No.

10/604,641

Examiner

José V. Chen

Applicant(s)/Patent under Reexamination

PONZIO, MASSIMO

Art Unit

3637

SEARCHED

Class	Subclass	Date	Examiner
100	55.1 55.3 57.11	3/22/06	JVC
198	803.0 803.01		
269	56 55 292		
JPDAES		10/17/06	JVC
JPDAES		4/16/07	JVC

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR
For & back Sources For back list	3/22/06	JVC
JPDAES	10/17/06	JVC
JPDAES	4/16/07	JVC